

**ORIO BELLEZZA**  
**President, Technology, Manufacturing and Quality**  
**STMicroelectronics**

Orio Bellezza is STMicroelectronics' President, Technology, Manufacturing and Quality, and has held this position since May 31<sup>st</sup>, 2018. He has been responsible for Front-End Manufacturing since 2008 and his mandate has been expanded to cover ST's technology, manufacturing operations, supply chain, and quality. Bellezza is a member of ST's Executive Committee since May 31<sup>st</sup>, 2018.

Bellezza joined SGS-ATES, a predecessor company to STMicroelectronics, in 1984 as a fab process engineer. He soon moved to ST's Central R&D organization and participated in several key projects, including the introduction of process technology modules for manufacturing sub-micron non-volatile memories. In 1996, Bellezza was appointed Director of ST's R&D facility in Agrate and led its upgrade and expansion into a manufacturing and development center for non-volatile memory and smart-power technologies. In 2002, he became Vice President of Central R&D, and in 2005, was appointed Vice President and Assistant General Manager of Front-End Technology and Manufacturing.

Bellezza has published technical papers and earned several patents in non-volatile memories.

Orio Bellezza was born in Bergamo, Italy, in 1959, and graduated cum laude with a degree in Chemistry from the University of Milan, Italy.

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